



PATENT  
Attorney Docket No.: 16869P-004610US  
Client Ref. No.: 219800332US2

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of:

YUKIHIRO SHIBATA *et al.*

Application No.: 10/761,493

Filed: January 20, 2004

For: METHOD AND APPARATUS  
FOR OBSERVING AND  
INSPECTING DEFECTS

Customer No.: 20350

Confirmation No.: 4371

Examiner: Tu T. Nguyen

Technology Center/Art Unit: 2877

**AMENDMENT**

**Mail Stop Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed February 22, 2005, please enter the following amendments and remarks:

**Amendments to the Abstract** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.